

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroyuki NAGASAKA

Application No.: 10/589,962

Filed: August 18, 2006

Docket No.: 128675

For: EXPOSURE METHOD, EXPOSURE APPARATUS, EXPOSURE SYSTEM AND
DEVICE MANUFACTURING METHOD

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please consider the following:

Amendments to the Specification; and

Remarks.